



SPICA

Mid-Infrared Camera and Spectrometer

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Instrument Overview

5 -- 38 μm (--50 μm) Camera and Spectrometer

■ Wide Field Camera

- 5 arcminutes square FOV x 2, $\lambda\lambda$ 5--25 and 20--38 μm

■ High Resolution Spectrograph

- $R \sim 30,000$ $\lambda\lambda$ 4--8 μm and 12--18 μm

■ Mid Resolution Spectrograph

- IFU by image slicer
- $R \sim 1500$ --700 $\lambda\lambda$ (10--20)+(20--36) μm at once

■ Low Resolution Spectrograph

- $R \sim 50$ --100 $\lambda\lambda$ 5-26 μm and (20-38 or 25-48) μm



Membership

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Scientific objectives

- Resolution of Birth and Evolution of Galaxies
- Thorough Understanding of Planetary System Formation
- The Transmigration of Dust in the Universe



--- Today's topics ---

We will show

- Specifications of the instrument
- Current design
- Status of developments

and also talk about

- Feasibility of the specifications
- Priority in the development process.

Please discuss

- What is important in the future?
- Modifications of the specifications.



Spec.: Wide-Field-Camera (WFC)

- FOV: 5' x 5' x 2 field WFC-S and WFC-L
- Diffraction limited image
- Zodiacal light limit noise
- WFC-S
 - 5 -- 25 μ m
 - Si:As 2048x2048 pixels 0."146 fov/pix
- WFC-L
 - 20 -- 38 μ m
 - Si:Sb 1024x1024 pixels 0."293 fov/pix



Spec.: High Resolution Spectrograph (HRS)

- Immersion Grating based High Resolution

- HRS-L

- Si:As 2048 x 2048 detector
- 12 -- 18 μm $R \sim 20,000$ -- 30,000
- 6".0 x 1".2 long slit
- 0".48 /pix

- HRS-S

- Si:As 2048 x 2048 detector
- 4 -- 8 μm $R \sim 30,000$
- 3".5 x 0".72 long slit
- 0".288 /pix



Spec.: Mid Resolution Spectrograph (MRS)

- Integral Field Unit by Image slicer
- 2-octave wavelength coverage by dichroic filter
- MRS-L
 - Si:Sb 1024x1024 detector
 - 20 -- 36 μm $R\sim 700$
 - 12".0 x 2".5 slitlet x 5 = 12" x 12" FOV
 - 0".485 /pix
- MRS-S
 - Si:As 2048x2048 detector
 - 10 -- 20 μm $R\sim 1500$
 - 12" x 1".2 slitlet x 5 = 12" x 6" FOV (part of MRS-L FOV)
 - 0".403 /pix



Spec.: Low Resolution Spectrograph (LRS)

- Wide wavelength coverage
- High sensitivity
- LRS-S
 - 5 -- 26 μm covered by prism
 - 2'.5 x 1".40 long slit
 - $R \sim 50$ -- 100
- LRS-L
 - 20 -- 38 μm prism or grating
 - 2'.5 x 2".66 long slit
 - $R \sim 50$ -- 100



LRS issues

- High sensitivity is required. -- Feasible
- Choice of disperser and wavelength coverage
 - Prism : Wide coverage, Low Resolution, fab. Risk
 - Grating: Limited coverage, very feasible
 - Instantaneous wave length coverage for LRS-S
 - current plan : as wide as possible 5 -- 26 μ m
 - option 5 --10 μ m (outside MRS, competitive JWST) or
 - 10 -- 20 μ m (inside MRS, outside JWST)
 - Slit width should be optimized at longest wavelength

Extension to longer wavelength

- Detector technology up to 50 μ m is under development
- Risk:
 - Detector prop. is unknown
 - Easy to cancel the extension and back to Si:Sb based 38 μ m limit
- Cost:



Expected performance

■ WFC-S/L

- Point source, 1hr, 5σ
- 4.9 / 6.7 / 7.7 μJy for 20 / 30 / 38 μm
- 0.13 / 1.2 / 3.5 μJy for 5 / 10 / 20 μm

■ HRS-S/L

- Point source, 1hr, 5σ 8mJy(L) 3mJy(S)
- Diffuse , 1hr, 5σ 10 MJy/sr(L) 30 MJy/sr(S)

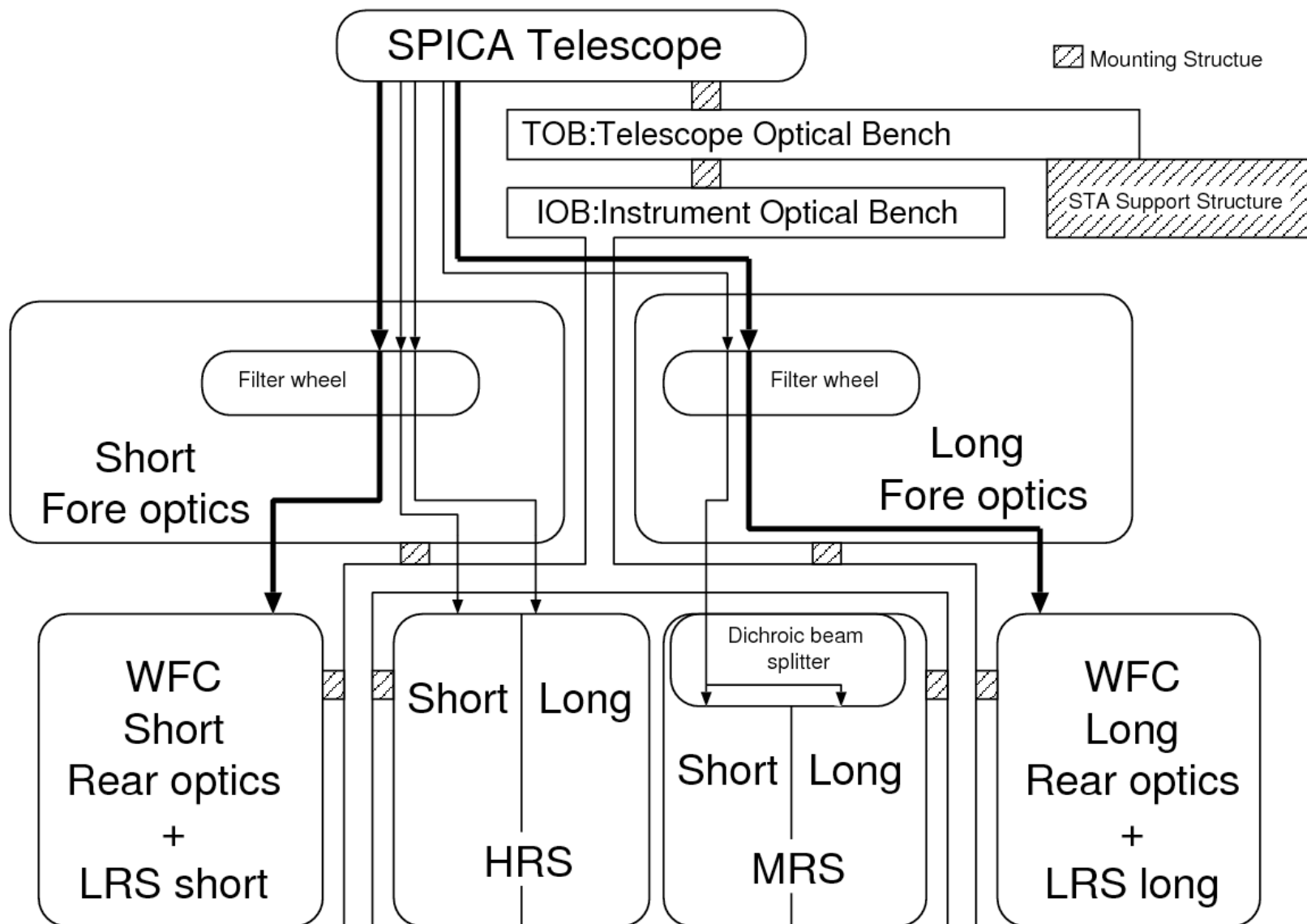
■ MRS-S/L

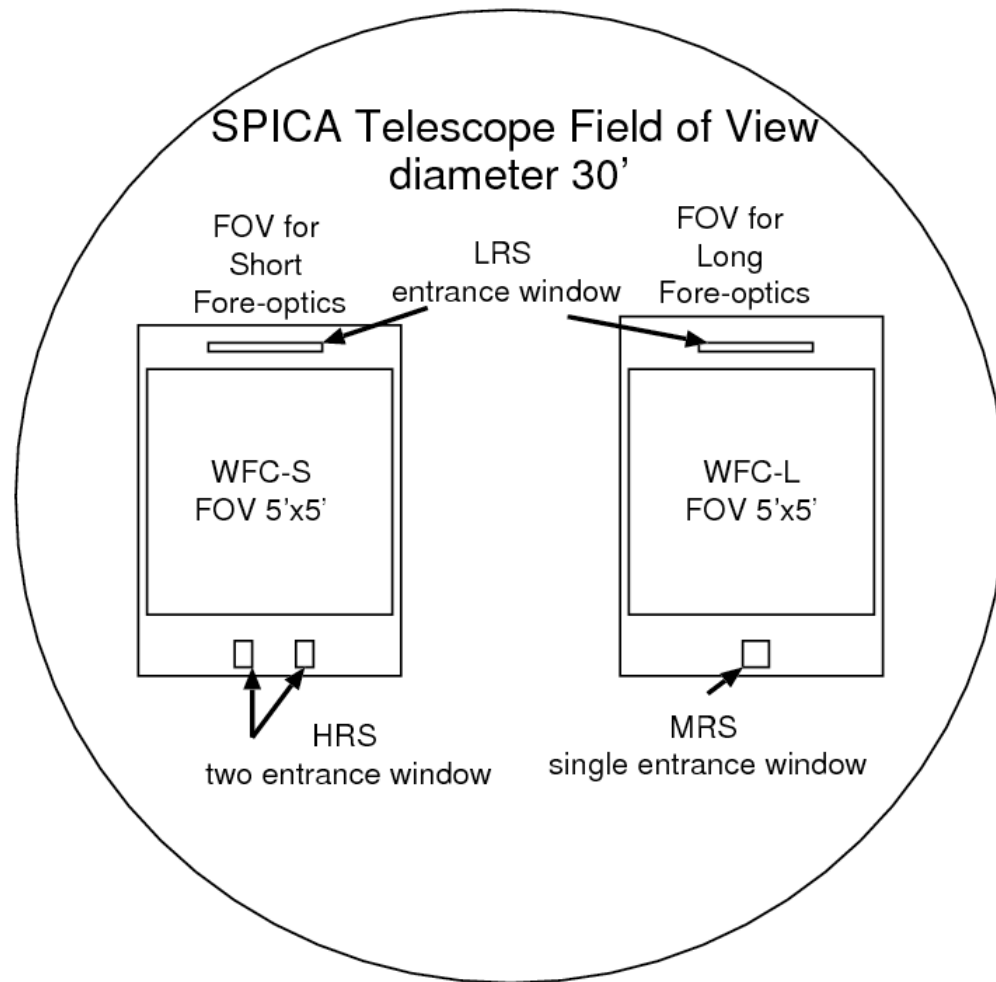
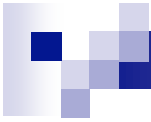
- Point source, 600sec, 5σ ~600 μJy (L) ~100 μJy (S)

■ LRS-S/L

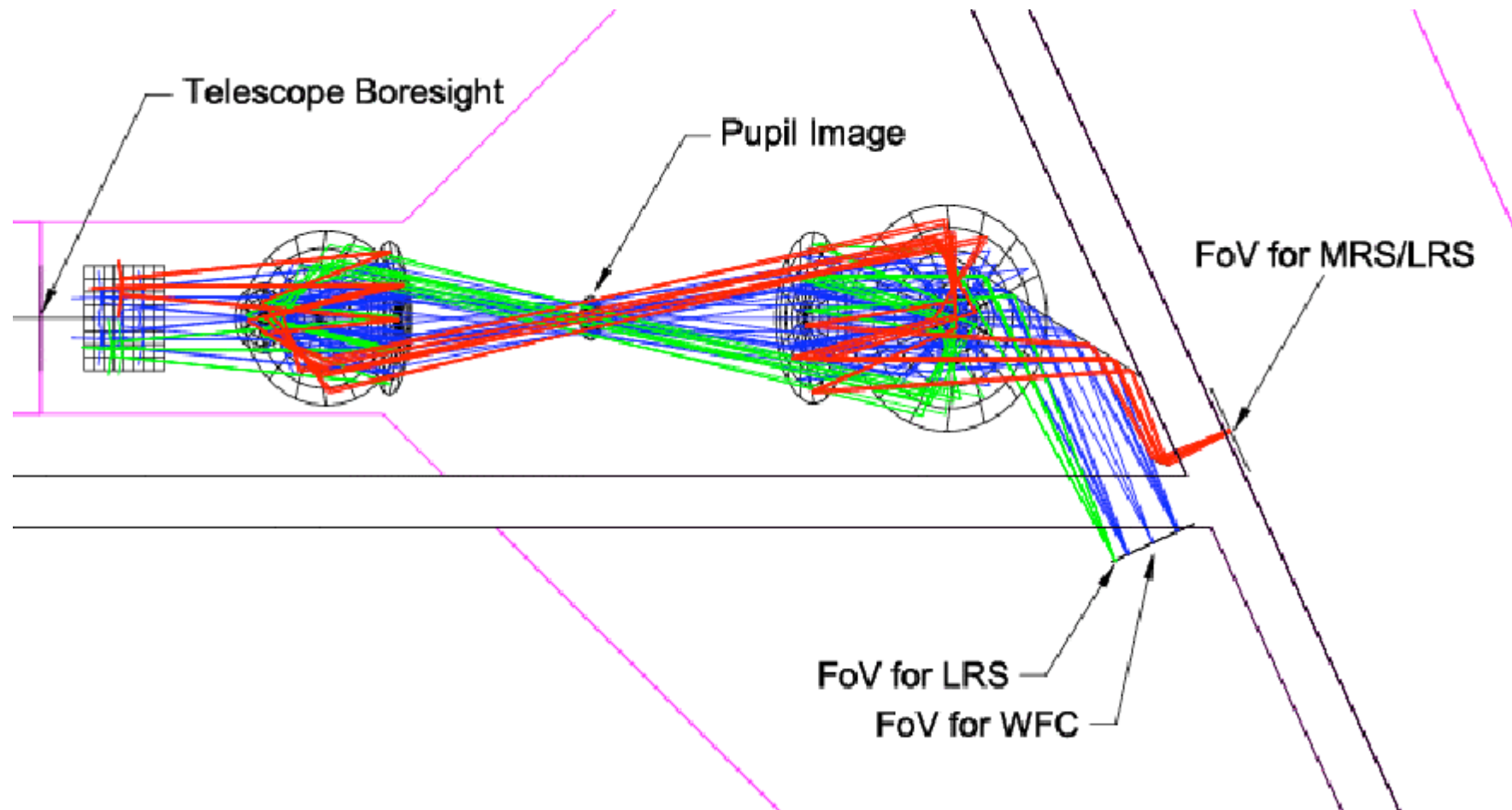
- Point source, 600sec, 5σ
- 64 / 84 / 108 / 136 μJy at 20 / 25 / 30 / 35 μm
- 7.3/14/26/39 μJy at 7.5 / 10 / 15 / 20 μm

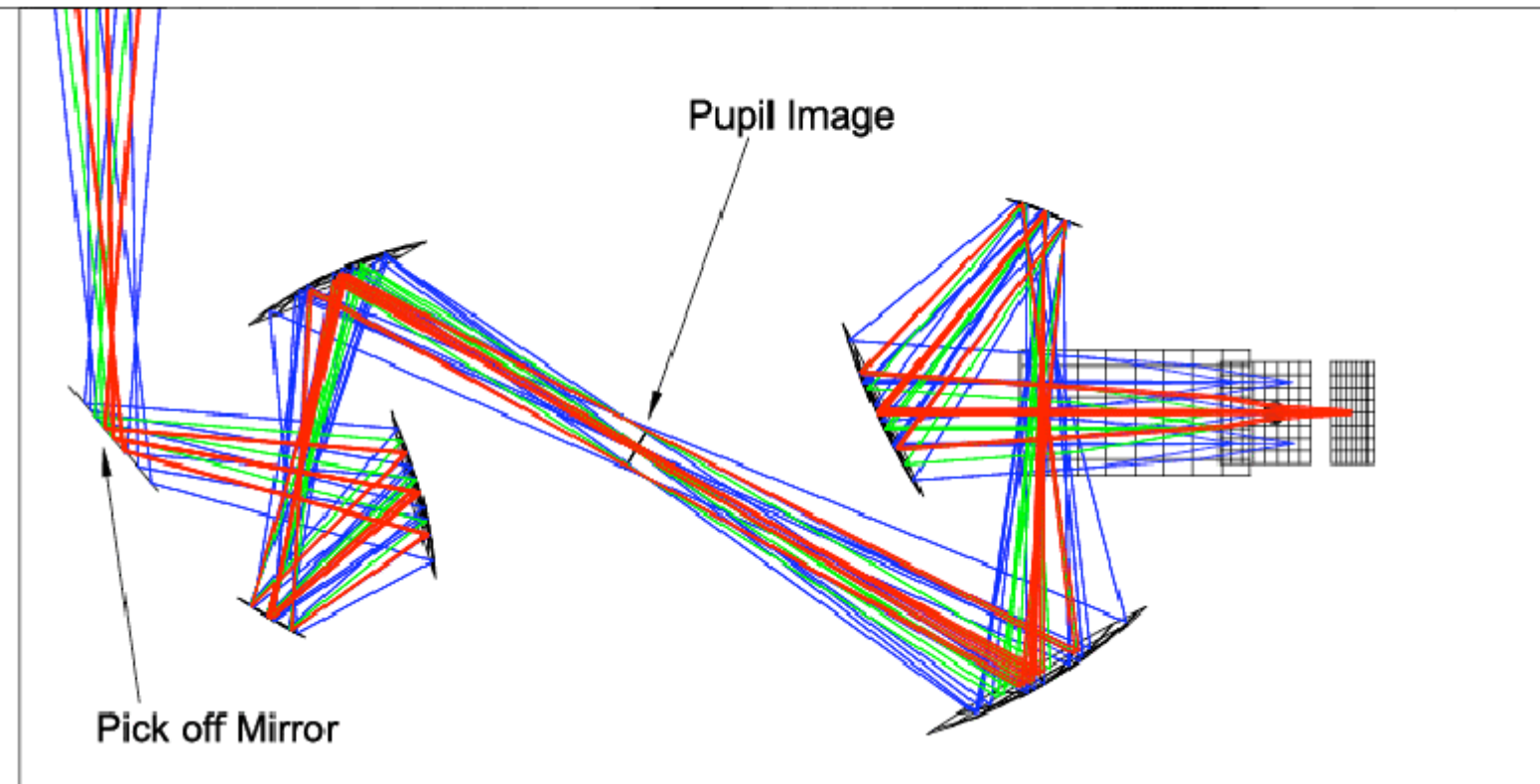
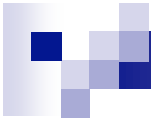
Design: Optical architecture





Design: Fore-optics



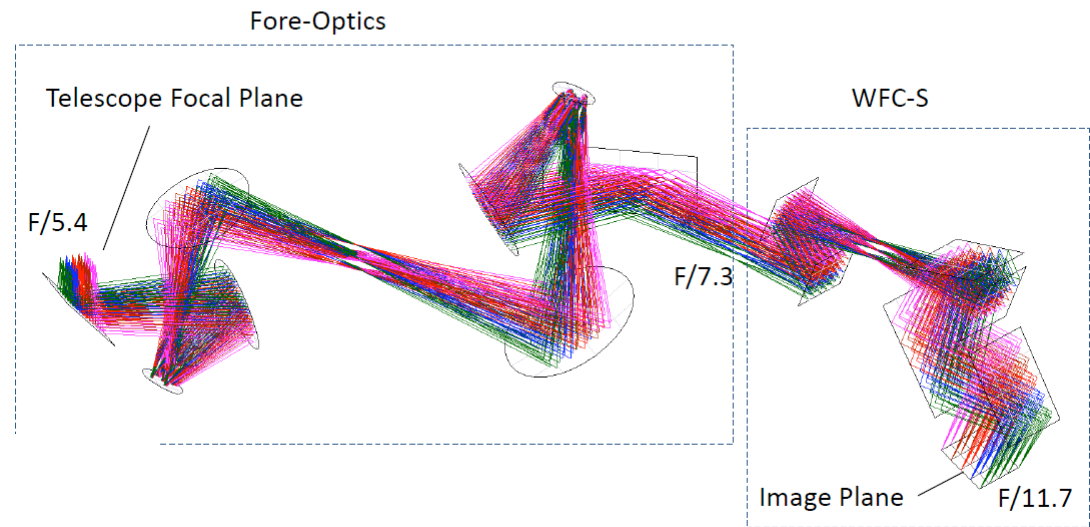




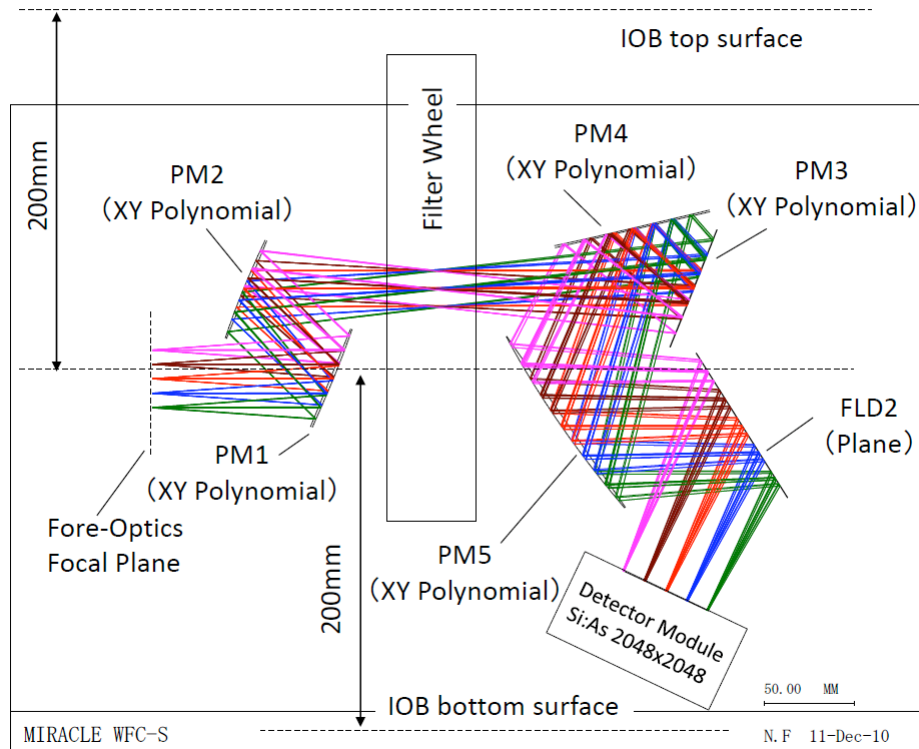
WFC-S 3D View

Design: WFC

■ WFC-S



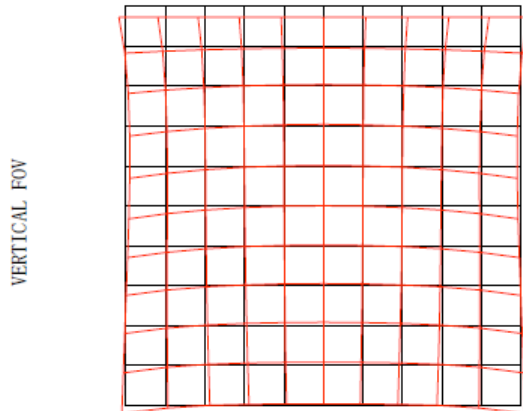
YZ Cross-Section



WFC-S

ディストーション

Anamorphic Ratio (Y/X) = 1.00238



最大5.45%

HORIZONTAL FOV

— Parax FOV
— Actual FOV

画角番号 ストレール比
 @波長5um

FIELD POSITION	画角番号	ストレール比	RMS
1.00, 1.00	F15	0.969	0.044705
-.042, 0.208 DG			100% = 0.173109
1.00, 0.90	F14	0.905	0.059006
-.042, 0.188 DG			100% = 0.186399
1.00, 0.70	F13	0.897	0.056750
-.042, 0.146 DG			100% = 0.151961
1.00, 0.60	F12	0.969	0.042918
-.042, 0.125 DG			100% = 0.153191
1.00, 0.80	F11	0.884	0.051423
-.042, 0.167 DG			100% = 0.143878
0.50, 1.00	F10	0.937	0.047629
-.021, 0.208 DG			100% = 0.139538
0.50, 0.90	F9	0.958	0.036731
-.021, 0.188 DG			100% = 0.093192
0.50, 0.70	F8	0.948	0.039009
-.021, 0.146 DG			100% = 0.101713
0.50, 0.60	F7	0.978	0.039766
-.021, 0.125 DG			100% = 0.146600
0.50, 0.80	F6	0.952	0.040494
-.021, 0.167 DG			100% = 0.081611
0.00, 1.00	F5	0.955	0.043095
0.000, 0.208 DG			100% = 0.120823
0.00, 0.90	F4	0.926	0.042700
0.000, 0.188 DG			100% = 0.077014
0.00, 0.70	F3	0.914	0.053277
0.000, 0.146 DG			100% = 0.106202
0.00, 0.60	F2	0.959	0.042539
0.000, 0.125 DG			100% = 0.121616
0.00, 0.80	F1	0.889	0.064531
0.000, 0.167 DG			100% = 0.112385

DEFOCUSING

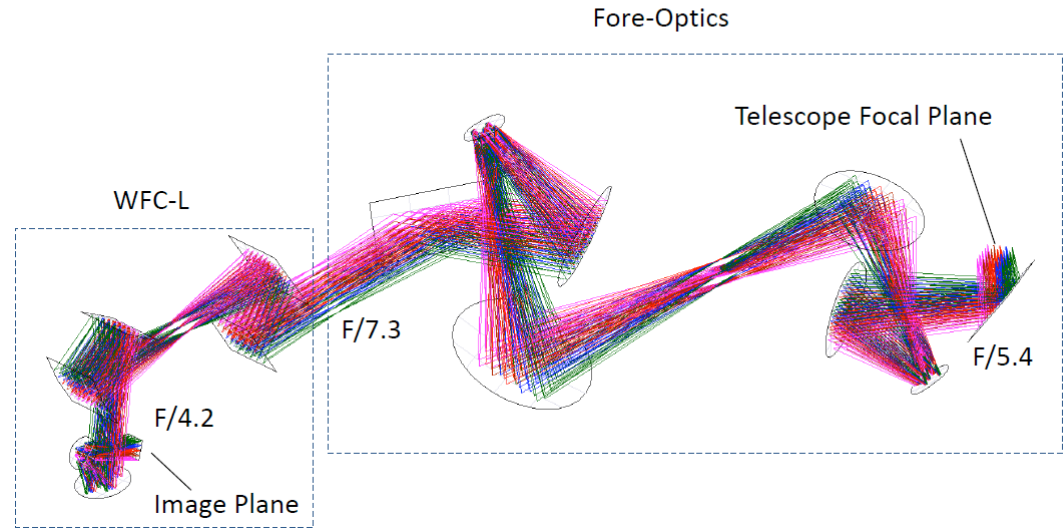
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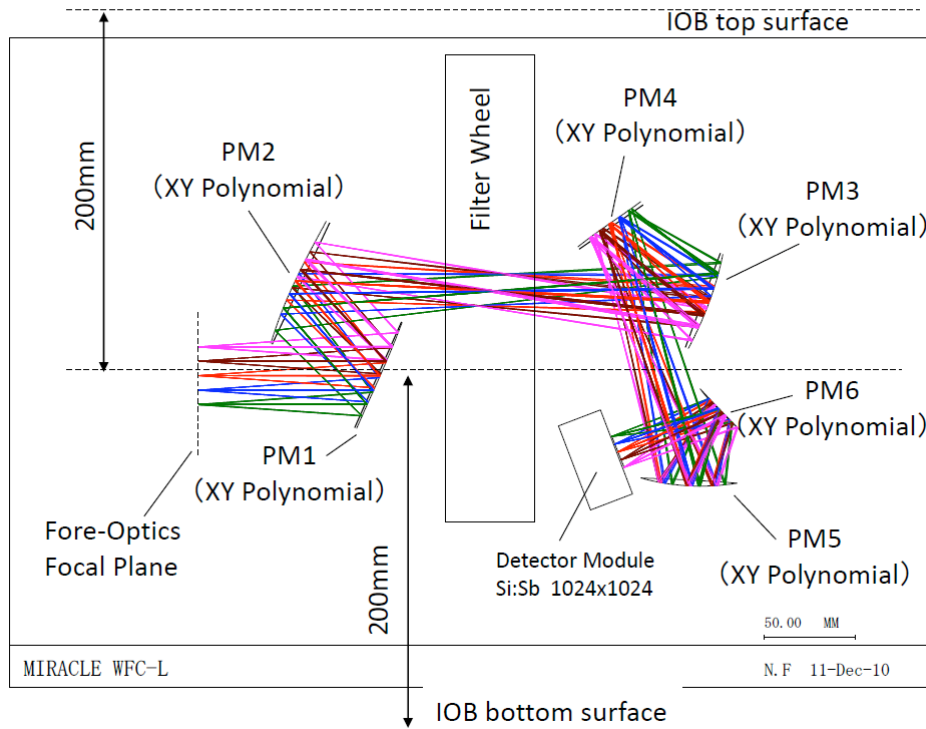


WFC-L 3D View

■ WFC-L



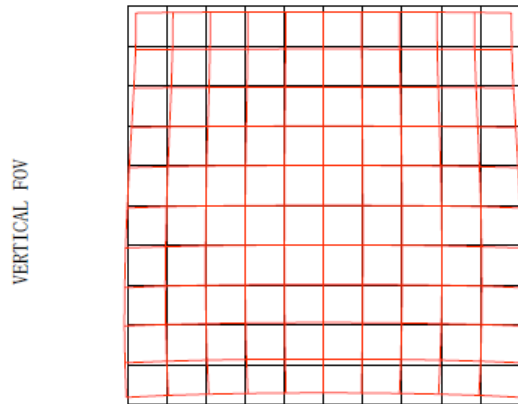
YZ Cross-Section



WFC-L

ディストーション

Anamorphic Ratio (Y/X) = 1.00783



最大5.79%

HORIZONTAL FOV

— Parax FOV
— Actual FOV

画角番号 ストレール比
 @波長5um

FIELD POSITION	画角番号	ストレール比	RMS
1.00, 1.00	F15	0.955	0.019084
-.042, 0.208 DG			100% = 0.059885
			RMS = 0.016821
1.00, 0.90	F14	0.936	
-.042, 0.188 DG			100% = 0.043715
			RMS = 0.021649
1.00, 0.70	F13	0.872	
-.042, 0.146 DG			100% = 0.051436
			RMS = 0.013933
1.00, 0.60	F12	0.975	
-.042, 0.125 DG			100% = 0.042373
			RMS = 0.016407
1.00, 0.80	F11	0.904	
-.042, 0.167 DG			100% = 0.034428
			RMS = 0.019179
0.50, 1.00	F10	0.912	
-.021, 0.208 DG			100% = 0.062111
			RMS = 0.017396
0.50, 0.90	F9	0.947	
-.021, 0.188 DG			100% = 0.046306
			RMS = 0.013752
0.50, 0.70	F8	0.964	
-.021, 0.146 DG			100% = 0.037329
			RMS = 0.019390
0.50, 0.60	F7	0.949	
-.021, 0.125 DG			100% = 0.069673
			RMS = 0.016470
0.50, 0.80	F6	0.939	
-.021, 0.167 DG			100% = 0.035465
			RMS = 0.016052
0.00, 1.00	F5	0.942	
0.000, 0.208 DG			100% = 0.048490
			RMS = 0.021636
0.00, 0.90	F4	0.911	
0.000, 0.188 DG			100% = 0.050517
			RMS = 0.013568
0.00, 0.70	F3	0.979	
0.000, 0.146 DG			100% = 0.038112
			RMS = 0.022047
0.00, 0.60	F2	0.925	
0.000, 0.125 DG			100% = 0.077381
			RMS = 0.022725
0.00, 0.80	F1	0.914	
0.000, 0.167 DG			100% = 0.043359

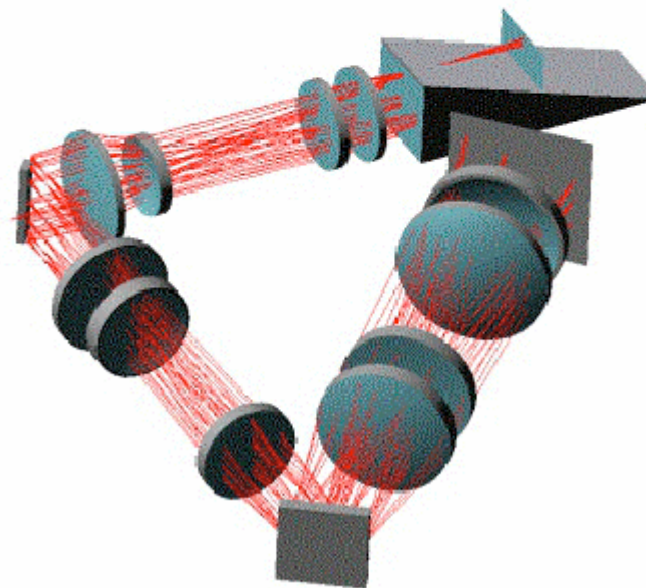
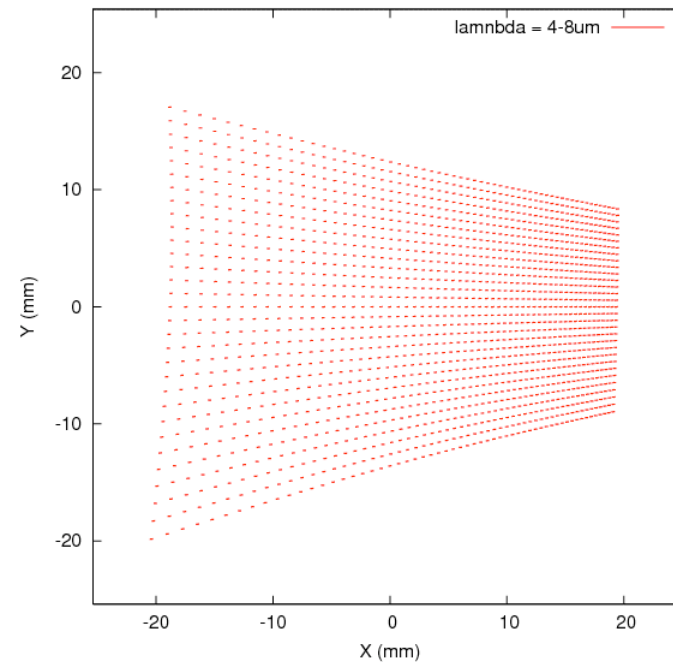
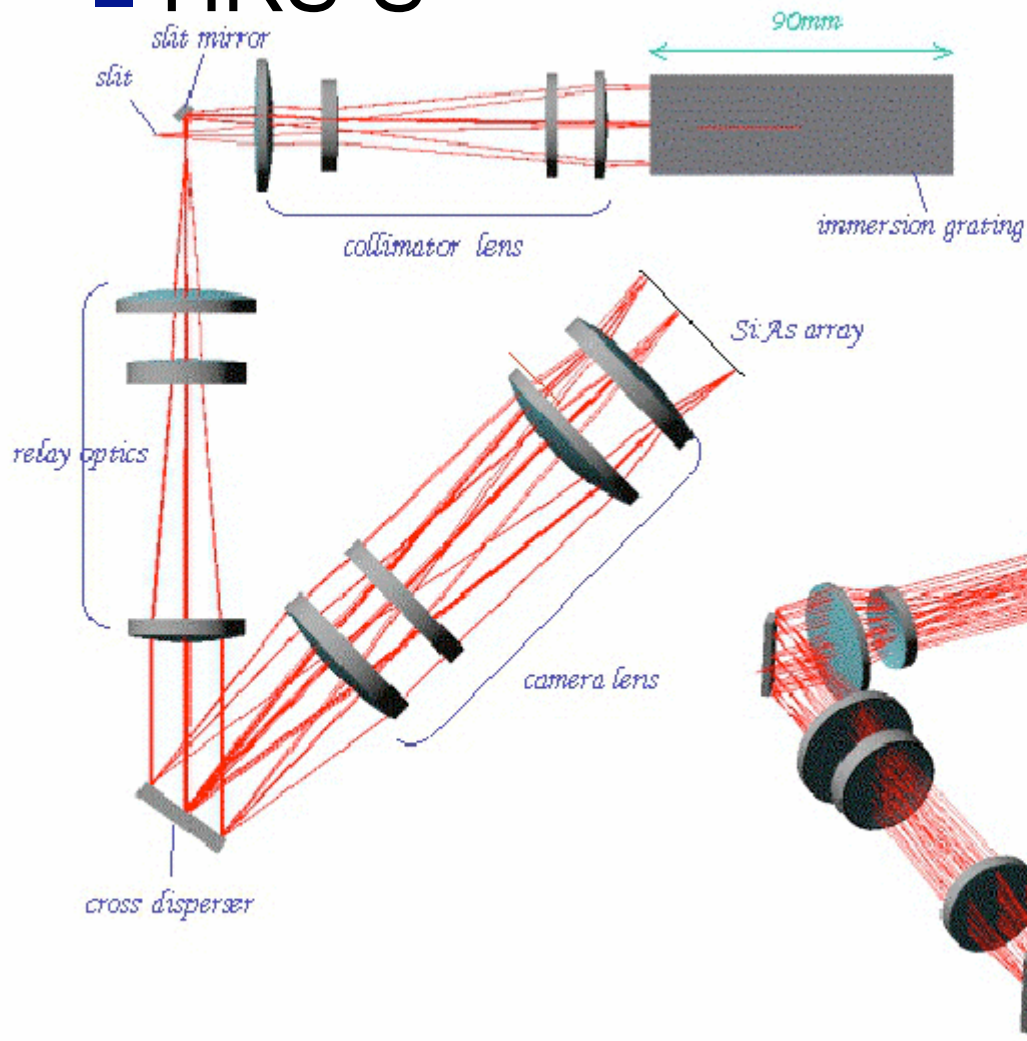
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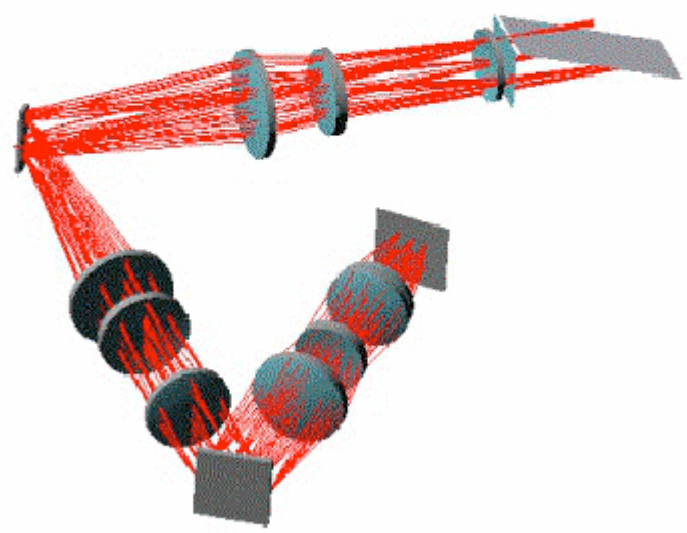
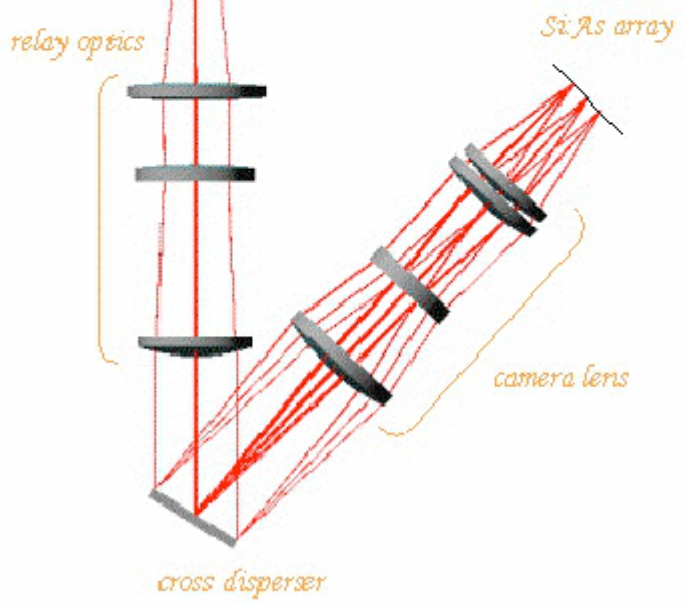
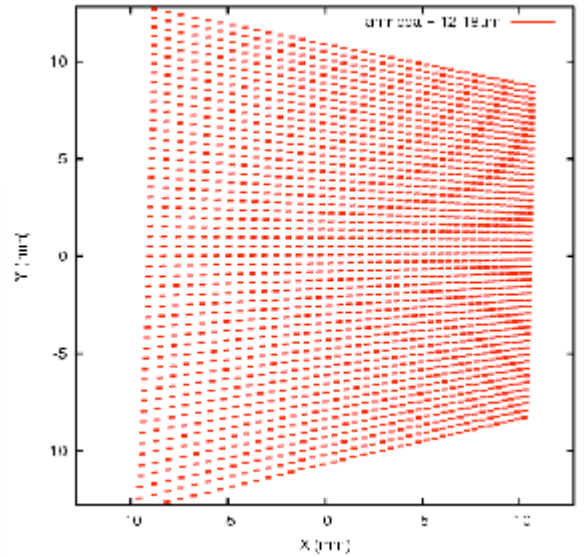
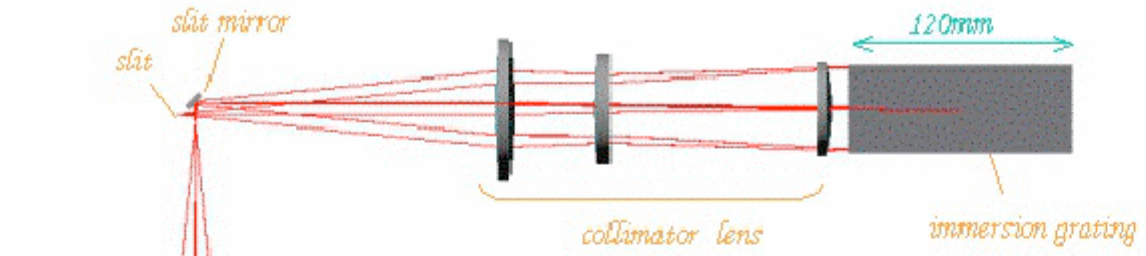
MM

Design: HRS

HRS-S

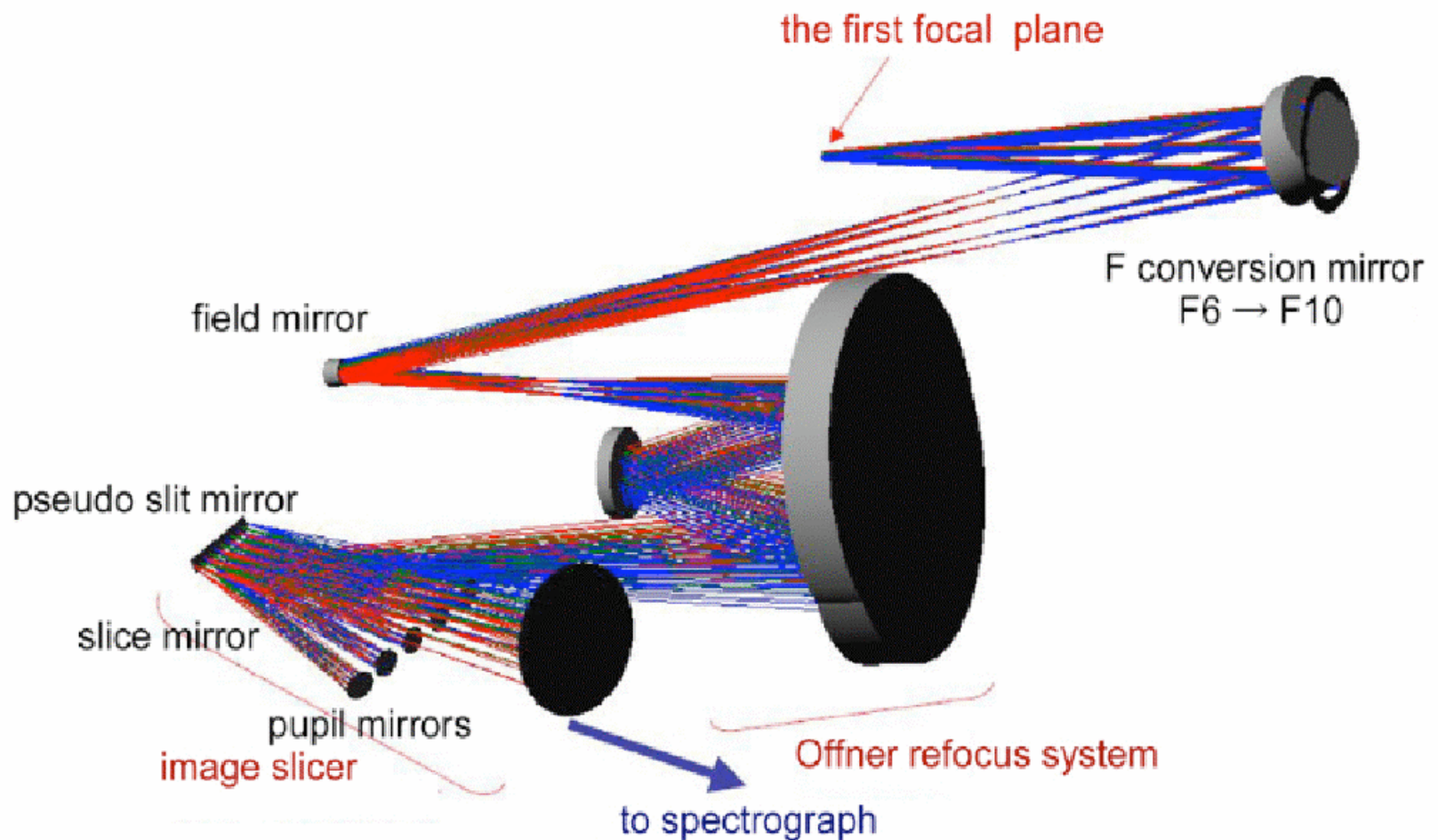


HRS-H

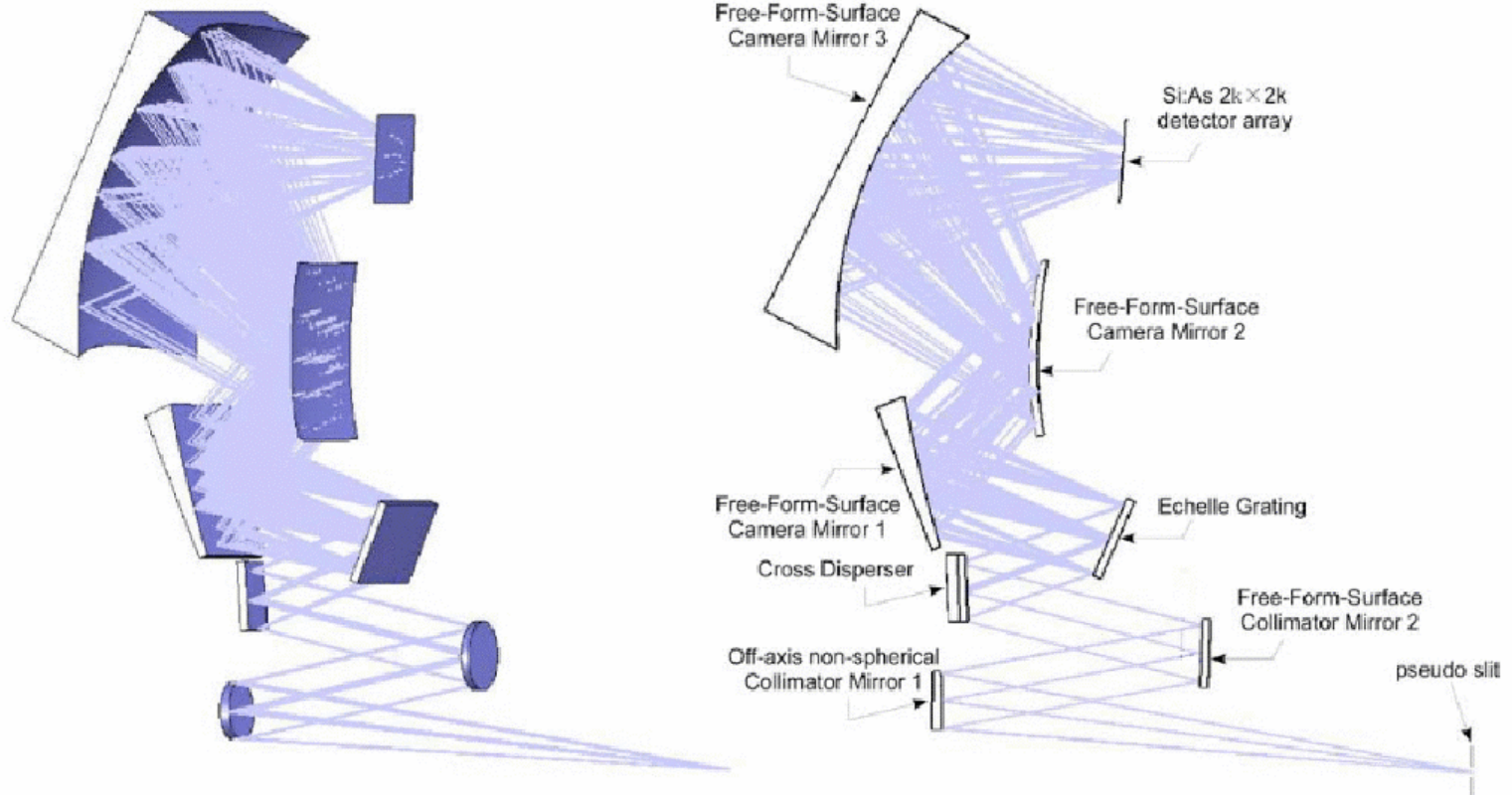
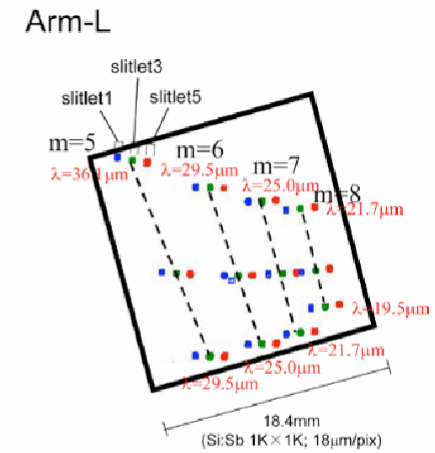
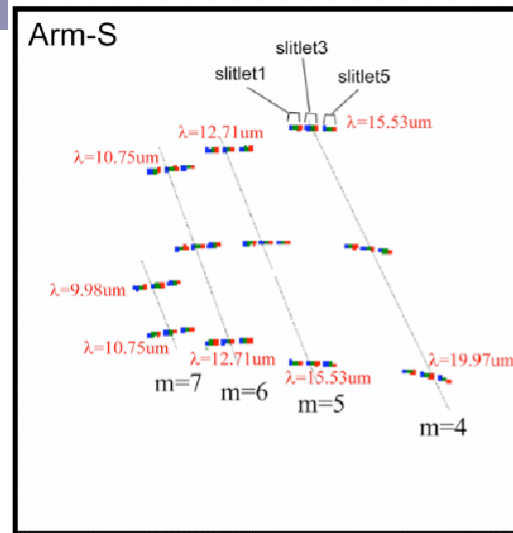


Design: MRS

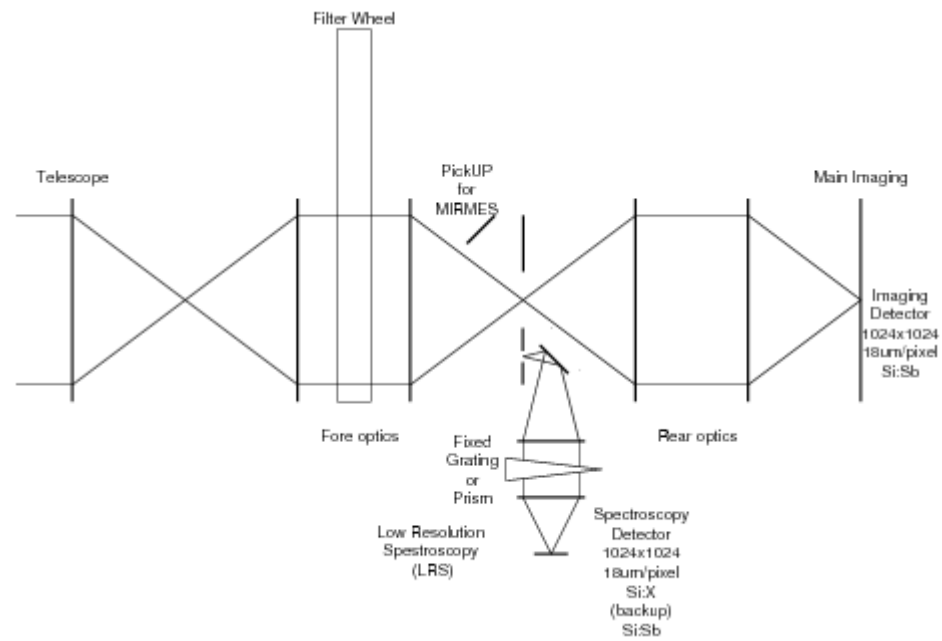
■ Slicser



■ spectrograph



Design: LRS



Design: Heat and Mass

- Thermal design:
 - VERY Limited resource
 - Operation mode is limited, Clear the resource limit

- Mass budget:
 - Rough estimate, Within the budget

Table 20: Operation mode and heat load

Mode	20K (mW)	4.5K (mW)	1.7K (mW)	note
Standby Allocated	TBD	0.4	0.3	
Observing Allocated	TBD	4.0	2.1	
Standby	2.24	0.18	<0.01	
WFC-S/L + LRS-S/L	13.4	3.6	2.0	Frame rate 1Hz(WFC-L,LRS-L), 1/4Hz(WFC-S,LRS-S)
WFC-S/L + MRS-S/L	13.4	3.6	2.0	Frame rate 1Hz(WFC-L,MRS-L), 1/4Hz(WFC-S,MRS-S)
WFC-S/L + HRS-S/L	10.64	3.6	1.0	Frame rate 1Hz(WFC-L), 1/4Hz(WFC-S), 1/8Hz(HRS-S/L)



Devel.: Detector

- Si:Sb 1024 x 1024

- On going development. Budget limited.

- Si:As 2048 x 2048

- JWST Heritage, Start to develop.

- Budget limited

- Si:As High dope 1024x1024

- Development by another US project. (We can get information.)



Devel.: Optical elements

■ Immersion Grating

- HRS-S : ZnSe final development phase
- HRS-L : CdTe Now, look hopeful

■ Filter, Prism, Mirror, Lens, and etc

- On going development.
- Man power / technology / budget limit